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OFFICE OF PETITIONS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/072,440
Confirmation No. 2639
Filing Date February 5, 2002
Inventor..... H. Daniel Dulman
Assignee..... Micron Technology, Inc.
Group Art Unit..... 1756
Examiner Stephen D. Rosasco
Attorney's Docket No. MI22-1829
Customer No. 021567
Title: Radiation Patterning Tools, And Methods Of Forming Radiation Patterning Tools

PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Mail Stop 313(c)
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

From: David G. Latwesen (Tel. 509-624-4276; Fax 509-838-3424)
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AMENDMENTS